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Docket No. NEC2320-USDIV SAI.023DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Allowed: July 1, 2004

Junya ISHII

Confirmation No. 5980

Application No.: 10/660,753

Group Art Unit: 2825

Filing Date:

September 12, 2003

Examiner:

Lee, Calvin

For: SEMICONDUCTOR DEVICE AND TEST METHOD FOR MANUFACTURING SAME

Honorable Commissioner of Patents Alexandria, Virginia 22313-1450

SUBMISSION OF CORRECTED FORMAL DRAWING

Sir:

Submitted herewith is corrected formal drawing for Figure 1 for the above-identified patent application, as requested by Examiner's Amendment/Form PTOL-37, dated July 1, 2004.

Approval and acknowledgment of receipt are respectfully requested.

Date: 7/15/04

Respectfully submitted,

Fredric J. Zimmerman Registration No. 48,74

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